

241154US-0

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
YUUKI TAUCHI ET AL. : ATTN: APPLICATION DIVISION  
SERIAL NO: NEW NON-PROVISIONAL  
APPLICATION :  
FILED: HEREWITH :  
FOR: Ag BASE ALLOY THIN FILM AND  
SPUTTERING TARGET FOR FORMING  
Ag BASE ALLOY THIN FILM

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the application identified above as follows.

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks** begin on page 19 of this paper.